

Application No. 10/567,344

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Applicant : Yoav Paltieli et al.  
Appl. No. : 10/567,344  
Filed : 6 February 2006  
Title : Method And Apparatus For Monitoring Labor Parameters  
Group Art Unit: 3737  
Examiner : Baisakhi Roy  
Docket No. : 1312PAL-US  
Honorable Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action of September 24, 2009, please amend the above-identified application as follows: